

<p>FORM PTO-1449  INFORMATION DISCLOSURE CITATION IN AN APPLICATION  (Use several sheets if necessary)</p>			Docket Number (Optional)		Application Number 09/536,952 Not Yet Assigned		
			YOR9-2000-0186US1		Applicant		
			Breen et al.		Filing Date		
			April 20, 2000		Group Art Unit 1734 Not Yet Assigned		
<b>U. S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	4,916,115	4/10/90	Mantese et al.	505	1		
	4,952,556	8/28/90	Mantese et al.	505	1		
	5,512,131	4/30/96	Kumar et al.	156	655.1		
	5,620,850	4/15/97	Bamdad et al.	530	300		
	5,900,160	5/4/99	Whitesides et al.	216	41		
	6,020,047	2/1/00	Everhart	428	209		
<b>FOREIGN PATENT DOCUMENTS</b>							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
<b>OTHER DOCUMENTS</b> (including Author, Title, Date, Pertinent Pages, Etc.)							
	<p>Organic-Inorganic heterostructure electroluminescent device using a layered perovskite semiconductor <math>(C_6H_5C_2H_4NH_3)_2PbI_4</math>, Era et al. in Appl. Phys Lett. 65 (6), 8 August '94 pp.676-678</p> <p>Manipulation of the Wettability of Surfaces on the 0.1- to 1-Micrometer Scale through Micromachining and Molecular Self-Assembly by Abbott et al., in Science, Vol. 257, 4 Sept. 1992, pp. 1380-1382</p> <p>Maskless photolithography: Embossed photoresist as its own optical element by Paul et al., in Applied Physics Letters, Vol. 73, No. 20, 16 Nov. 1998, pp. 2893-2895</p> <p>Patterning of dielectric oxide thin layers by microcontact printing of self-assembled monolayers by Jeon et al. in J. Mater. Res., Vol. 10, No. 12, dec 1995, pp. 2996-2999.</p>						
EXAMINER	DATE CONSIDERED 8/28/2001						
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							